

## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(PTO-1449)

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**49657-551**

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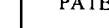
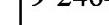
**APPLICANT**  
**Kazuhiro AIHARA, et al.**

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JIC564

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	9-246494	Sept. 19, 1997	JAPAN (with English abstract)				
	8-293494	Nov. 5, 1996	JAPAN (with English abstract)				

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

	"Optimum Electrode Materials for Ta <sub>2</sub> O <sub>5</sub> Capacitors for High- and Low-Temperature Processes", H. Matsuhashi et al., Jpn. J. Appl. Phys., Vol. 33 (1994), pp. 1293-1297	
EXAMINER 	J. MONDT	DATE CONSIDERED 

**EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.